

Notice of References Cited	Application/Control No. 10/754,539		Applicant(s)/Patent Under Reexamination TAKUJI ET AL.	
	Examiner Andy Huynh		Art Unit 2818	Page 1 of 1

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	B	US-6,314,021	11-2001	Maeda et al.	365/185.01
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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